

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**INFORMATION DISCLOSURE  
STATEMENT**

Docket Number:  
12013/50801

Application Number  
To Be Assigned

Filing Date  
Herewith

Examiner  
To Be Assigned

Art Unit  
To Be Assigned

Invention Title  
**LASER-INDUCED EXPLOSIVE EVAPORATION  
COATING METHOD, ASSOCIATED SYSTEM, AND  
DEVICE MADE BY THE METHOD**

Inventor(s)  
**Aiden Flanagan**

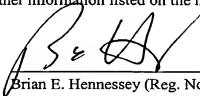
Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 35 U.S.C. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicant hereby bring the following reference to the attention of the Examiner. This reference is listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
2. A copy of each patent, publication or other information listed on the modified PTO Form 1449 is enclosed.

Dated:

2/18/04

By:



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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	<b>ATTY. DOCKET NO.</b> 12013/50801	<b>SERIAL NO.</b> To Be Assigned
	<b>APPLICANT</b> Aiden Flanagan	
	<b>FILING DATE</b> Herewith	<b>GROUP</b> To Be Assigned

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/ PUBLICATION NUMBER	PATENT/ PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,091,205	February 25, 1992	Fan			
	6,419,996	July 16, 2002	Mueller et al.			
	2001/0011545	August 9, 2001	Thompson et al.			

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

**OTHER DOCUMENTS**

Examiner Initials *	<b>AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.</b>
	P.K. WU, et al., "The Deposition, Structure, Pattern Deposition, and Activity of Biomaterial Thin-films by Matrix-assisted Pulsed-laser Evaporation (Maple) and Maple Direct Write," Thin Solid Films, Vols. 398-399, November 2001, pages 607-614.

<b>EXAMINER</b> /Cachet Sellman/	<b>DATE CONSIDERED</b> 04/23/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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